

| Type | L #     | Hits | Search Text  | DBs                      | Time Stamp       | Comments | Error Definition | Errors |
|------|---------|------|--|--------------------------|------------------|----------|------------------|--------|
| 1    | BRS L1  | 847  | (heat\$3 WITH crystalliz??\$2) AND ((irradiat??\$2 laser) WITH (crystal crystalli??\$2)) ((CRYSTALLIZ??\$2 WITH HEAT\$3) AND ((CRYSTALLI??\$2 OR CRYSTAL) WITH (anneal\$3))) | USPAT; EPO; JPO; Derwent | 2000/04/17 12:22 |          | 0                |        |
| 2    | BRS L2  | 733  |  | USPAT; EPO; JPO; Derwent | 2000/04/17 12:23 |          | 0                |        |
| 3    | BRS L3  | 1282 | 1 2  | USPAT; EPO; JPO; Derwent | 2000/04/17 12:23 |          | 0                |        |
| 4    | BRS L4  | 617  | 3 AND (insulating dielectric oxide nitride) ADJ2 (layer film substrate)  | USPAT; EPO; JPO; Derwent | 2000/04/17 12:26 |          | 0                |        |
| 5    | BRS L5  | 457  | 4 AND ((semiconductor silicon "gallium arsenide" GaAs) ADJ2 (FILM OR LAYER))   | USPAT; EPO; JPO; Derwent | 2000/04/17 12:28 |          | 0                |        |
| 6    | BRS L6  | 40   | 5 AND (mov??\$2 WITH laser)  | USPAT; EPO; JPO; Derwent | 2000/04/17 12:29 |          | 0                |        |
| 7    | BRS L7  | 27   | 6 AND (laser WITH (rectangular section elongated))   | USPAT; EPO; JPO; Derwent | 2000/04/17 12:37 |          | 0                |        |
| 8    | BRS L8  | 15   | 7 AND @ad<19960718   | USPAT; EPO; JPO; Derwent | 2000/04/17 12:40 |          | 0                |        |
| 9    | BRS L9  | 7    | (8 AND (@AD < "19950719"))   | USPAT; EPO; JPO; Derwent | 2000/04/17 12:58 |          | 0                |        |
| 10   | BRS L10 | 8    | 8 NOT 9  | USPAT; EPO; JPO; Derwent | 2000/04/17 12:58 |          | 0                |        |

EST reh

2/11/9. wsp

09/308,523